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JC17 Rec'd PCT/PTO 17 JUN 2005 ^{PATENT}

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Bertrand VIELLEROBE et al.

Conf.

Application No. **NEW NATIONAL PHASE**

Group

Filed June 17, 2005

Examiner

PARALLEL CONFOCAL LASER MICROSCOPY SYSTEM BASED ON VCSEL TECHNOLOGY

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

June 17, 2005

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begin on page 3 of this paper.

Remarks begin on page 7 of this paper.

An **Appendix** is attached following the signature page of this paper.